In re: Freese et al.

Application No.: 10/661,917 Filed: September 11, 2003

Page 3 of 3

## REMARKS

The present Amendment After Allowance is being filed to effectuate Applicants' previous change in the title. In particular, in Applicants' Amendment of June 23, 2006, Applicants changed the title of the present application to:

--METHODS FOR MASTERING MICROSTRUCTURES THROUGH A SUBSTRATE USING NEGATIVE PHOTORESIST--

Unfortunately, the Notice of Allowance does not reflect this change in the title. Accordingly, Applicants respectfully request the title be changed pursuant to the present Amendment, and that the issued patent reflect the correct title.

Respectfully submitted

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CERTIFICATION OF TRANSMISSION

I hereby certify that this correspondence is being transmitted via the Office electronic filing system in accordance with 37 CFR &t.6(a)(4) to the U.S. Patent and Mademark Office on September 13, 2010.

Susan E. Freedman

Date of Signature: September 13, 2010